

Docket No.: 071971-0390

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	
	:	
Kunimasa TAKAHASHI, et al.	:	
	:	
Application No.: Not yet assigned	:	Group Art Unit: Not yet assigned
	:	
Filed: October 20, 2005	:	Examiner: Not yet assigned
	:	
For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATION THE SAME		

PRELIMINARY AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please amend the application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Remarks / Arguments begin on page 7 of this paper.